

PATENT ABSTRACTS OF JAPAN

(11)Publication number : 10-238592

(43)Date of publication of application : 08.09.1998

(51)Int.Cl. F16F 15/129
F16F 15/123

(21)Application number : 10-018523

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(22)Date of filing : 30.01.1998

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(30)Priority

Priority number : 85 3512372 Priority date : 04.04.1985 Priority country : DE

85 3516907 10.05.1985

85 3532005 07.09.1985 DE

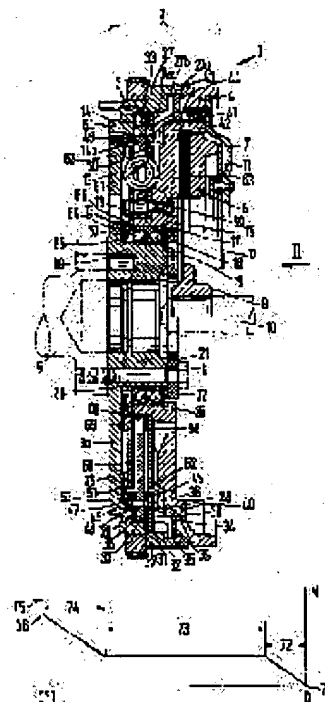
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(54) DEVICE HAVING BUFFER DEVICE LAID BETWEEN AT LEAST TWO FLYWHEEL MASS BODIES CAPABLE OF RELATIVELY TURNING FOR EACH OTHER

(57)Abstract:

PROBLEM TO BE SOLVED: To improve vibration damping capability by making the turning resistance of a buffer device variable for the number of revolutions or a centrifugal force, and installing a pressure accumulator effective in a peripheral direction and a pressure accumulator effective in an axial direction.

SOLUTION: The axis of abscissa relates to a turning angle across flywheel mass bodies 3 and 4, while the axis of ordinate shows the transmissible moment of an elastic torsional vibration damping device 13 and transmissible moment via a slide clutch 14 relates to the centrifugal force of a friction means 14a. The coil spring 63 of the damping device 13 is somewhat compressed, due to the relative turning motion of the flywheel mass bodies 3 and 4 from the non-acting position 71 thereof. Moment generated continues until becoming equal to the slide moment of a friction means 14b. Then, this friction means 14b slips to a turning angle 73, due to turning in the same direction. When the means 14b slips exceeding the angle 73, the spring 63 is further compressed, and a block is formed after the passage of the means 14b through a turning angle range 74. Furthermore, when moment exceeds a value transmissible via the friction means 14a, the flywheel mass bodies 3 and 4 become capable of giving a relative turning motion. As a result, the variation of the moment can be dampened or eliminated.



LEGAL STATUS

[Date of request for examination] 30.01.1998

[Date of sending the examiner's decision of rejection] 24.11.1999

[Kind of final disposal of application other than the examiner's decision of rejection or application converted registration]

[Date of final disposal for application]

[Patent number]

[Date of registration]

[Number of appeal against examiner's decision of rejection] 2000-02207

[Date of requesting appeal against examiner's decision of rejection] 22.02.2000

[Date of extinction of right]

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